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Cost Effective MEMS to Develop a Sustainable High Tech Business

Liquid Metal Alloy Interconnects



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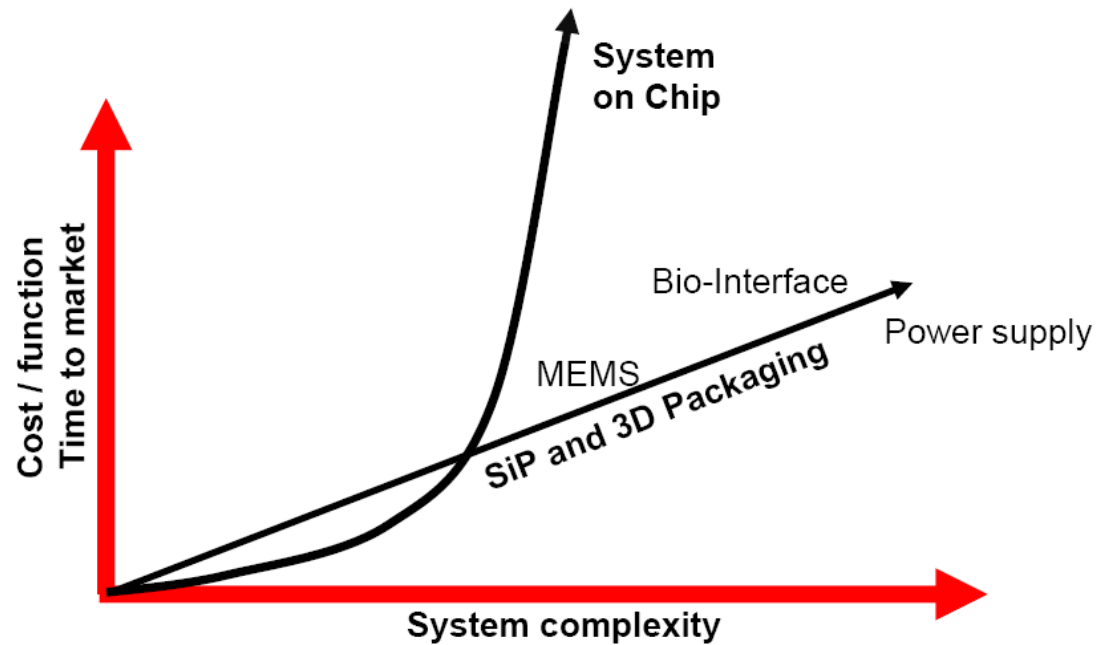
Liquid Metal Alloy Interconnects

“A Flexible Low Temperature Bonding Solution”

Content

- System integration solutions
- Liquid Metal Alloy
 - Advantages Liquid Interconnects
 - Ga-In Alloy
- Interconnection Process
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System Integration Solutions



Source: Fraunhofer IZM, Berlin Germany.

Advantages Liquid Interconnects

- Low temperature interconnection process
- Generic solution for heterogeneous systems
- Flexible solution (repair / re-use parts / prototyping)
- Reasonable electrical and thermal conductivity
- Interconnects are able to cope with CTE-mismatches

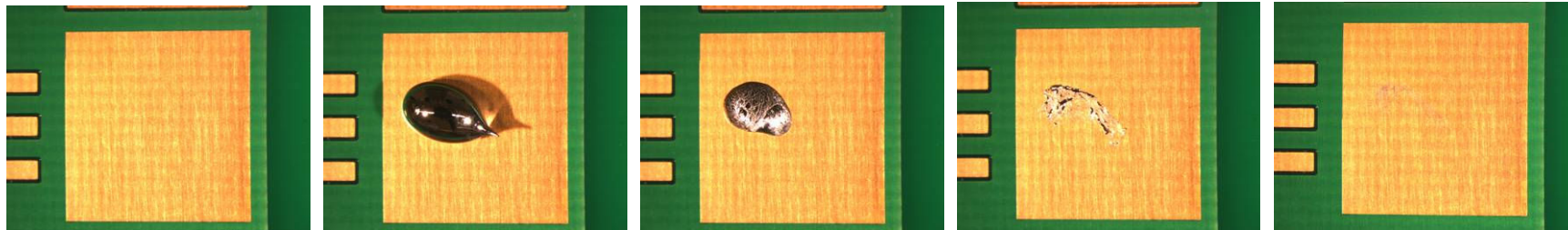
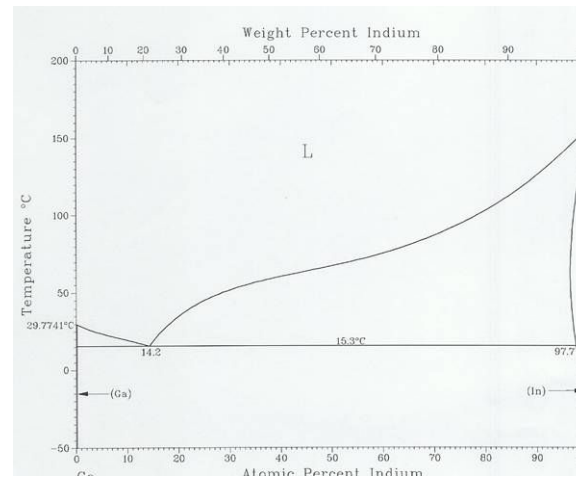
New process required!

Liquid Metal Alloy: Ga-In

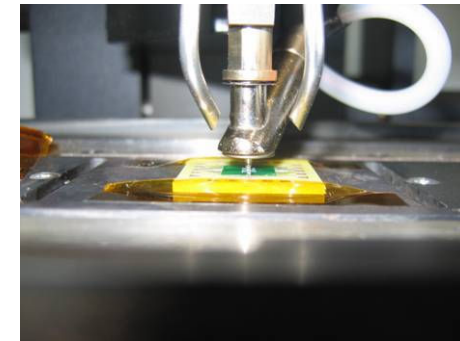
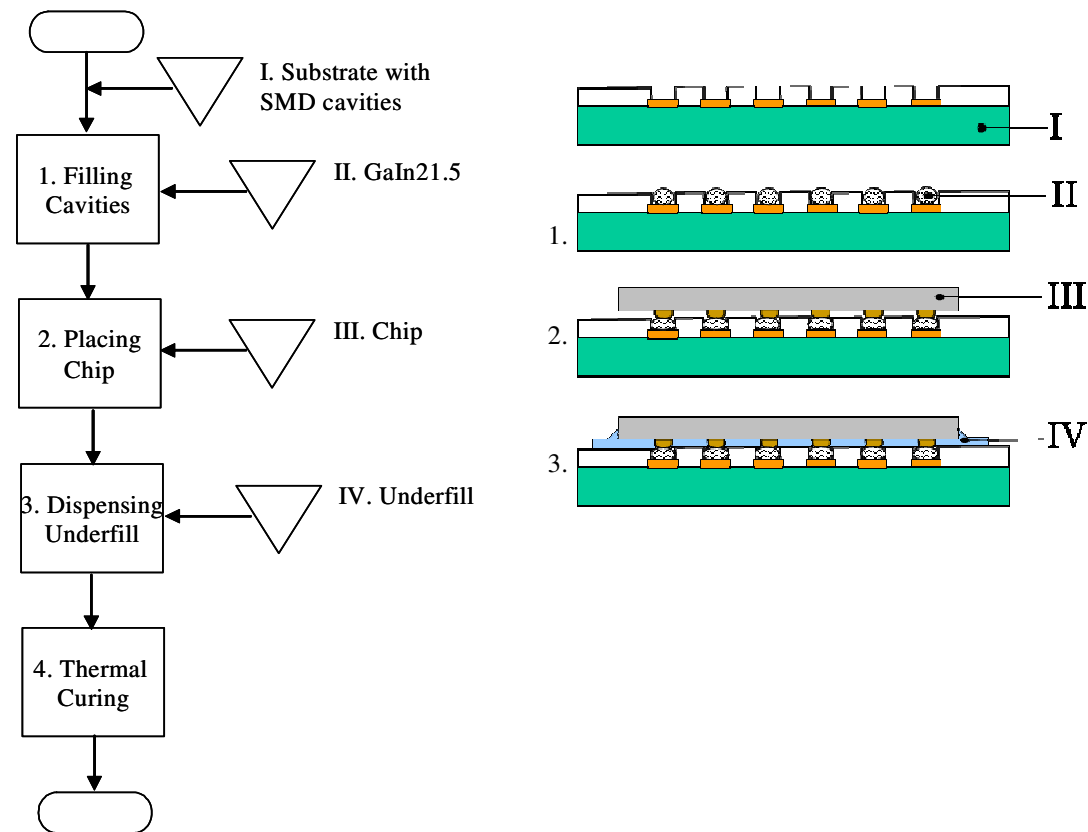
GaIn21.5wt.%

$T_{EUT} = 15.3\text{ }^{\circ}\text{C}$

Supplier: Mat-Tech



Interconnection Process



Low temperature bonding process ($< 100\text{ }^{\circ}\text{C}$) with Emerson & Cuming E1172A (fast flow snap cure capillary flow underfill)

Solder Mask Defined (SMD) Cavities

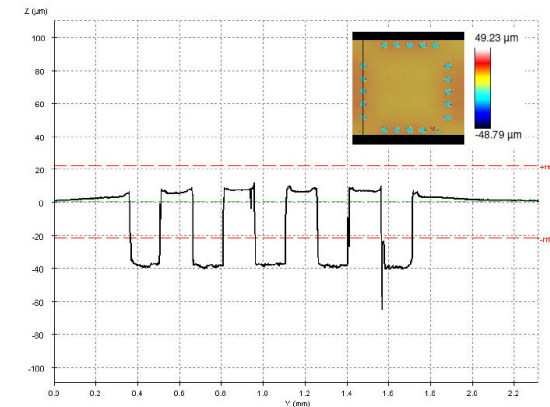
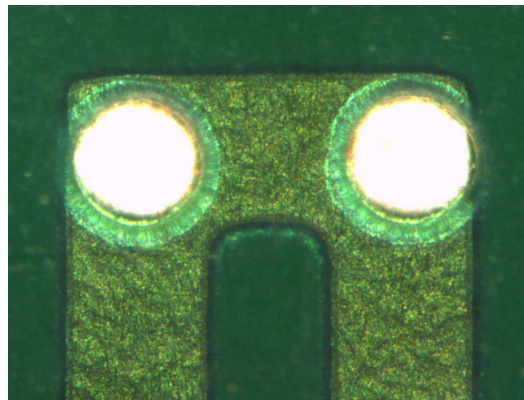
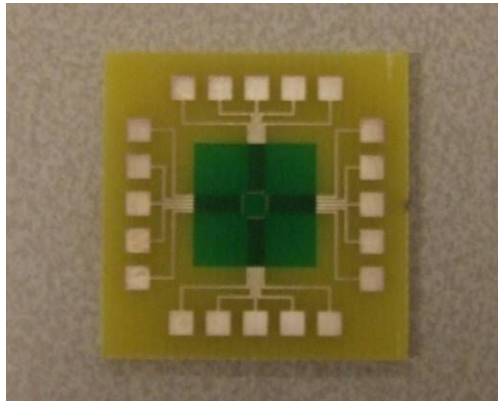
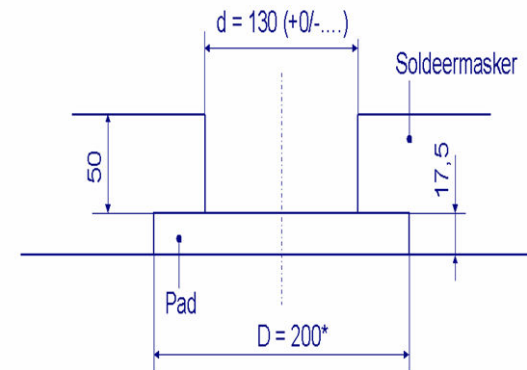
Substrate: FR4 (rigid)

Dimensions: 25 x 25 x 1,6 mm

Conductor: 17,5 μm Cu, Finish: Immersion Ag

Solder mask: dry film photoimageable (SMD)

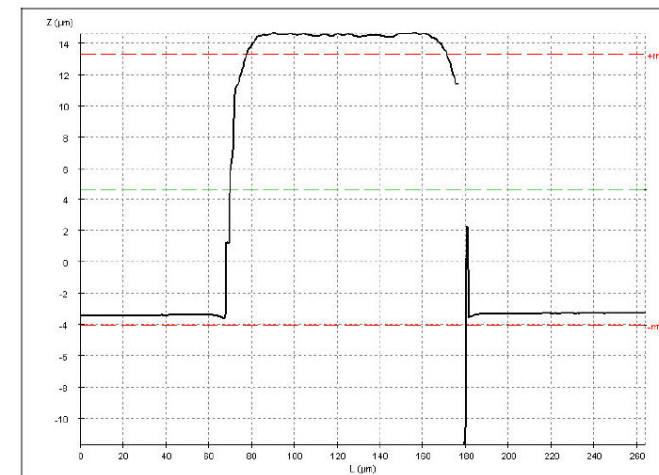
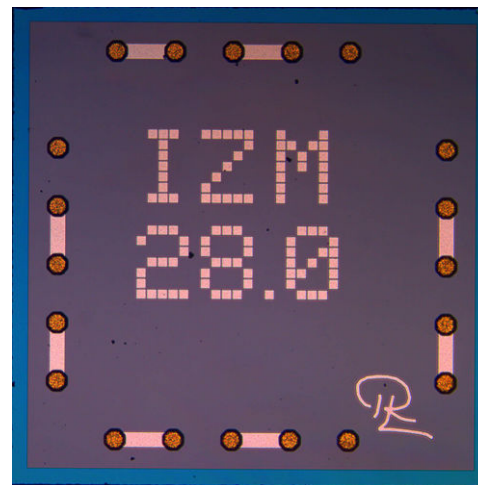
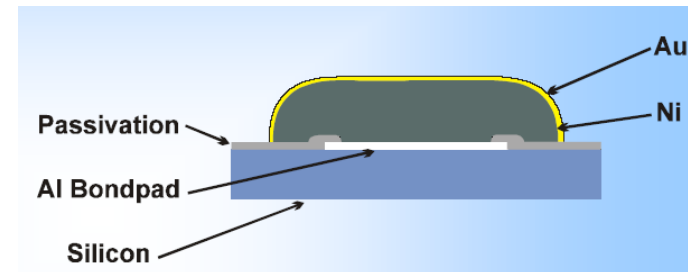
Manufacturer: Cyner Substrates



Chip and Bump Design

Daisy chain test chip designed and manufactured by Fraunhofer IZM

Dimensions: 2,5 x 2,5 mm (thinned by Disco till 150 μm), 20 I/Os, 300 μm pitch.
Bumps: Electroless Ni Immersion Au (20 μm height)



Applying Liquid Metal Alloy

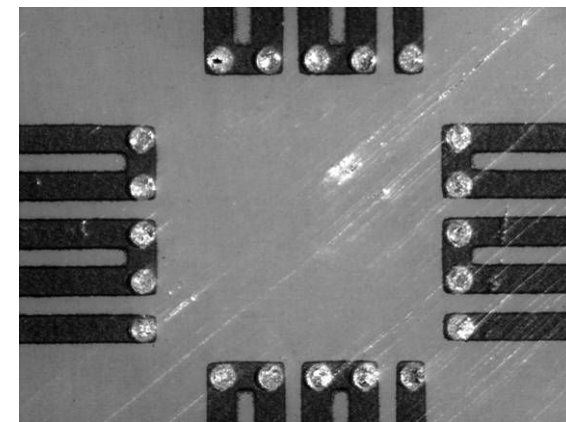
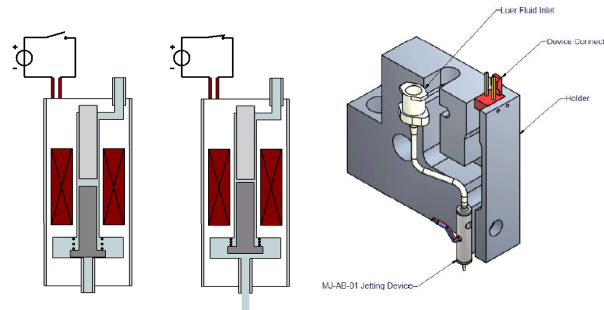
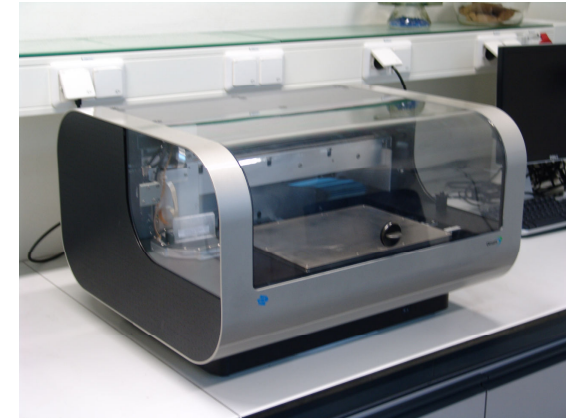
Tests to apply Galn24,5wt.% and Galn21,5wt.%

Dimatix printer: 3D translation system with disposable print cartridge/head combination

Valvejet: 80 μm nozzle diameter, drop sizes between 250 and 400 μm

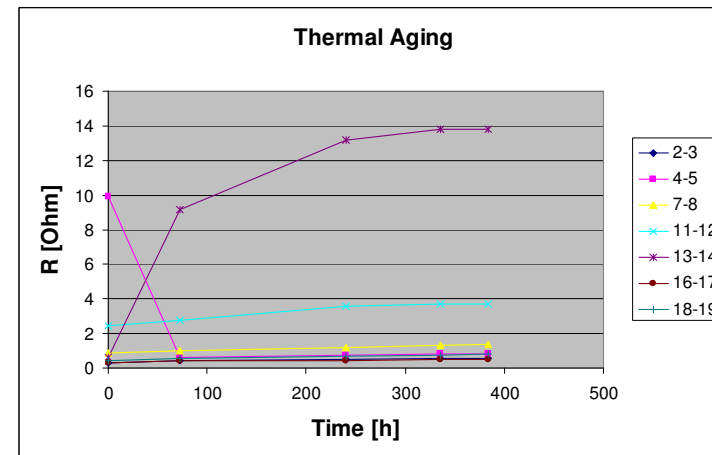
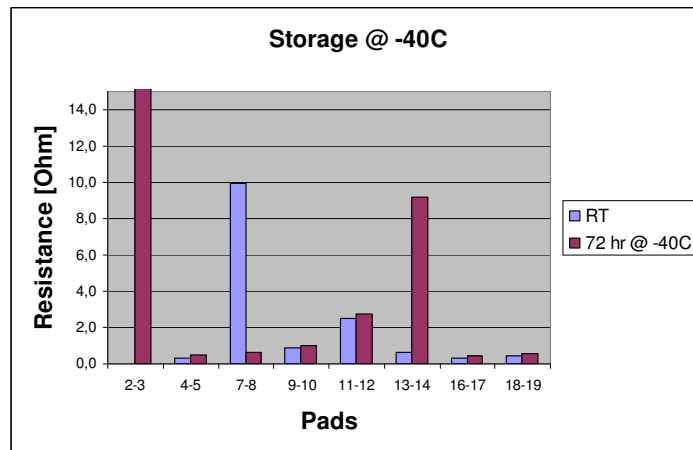
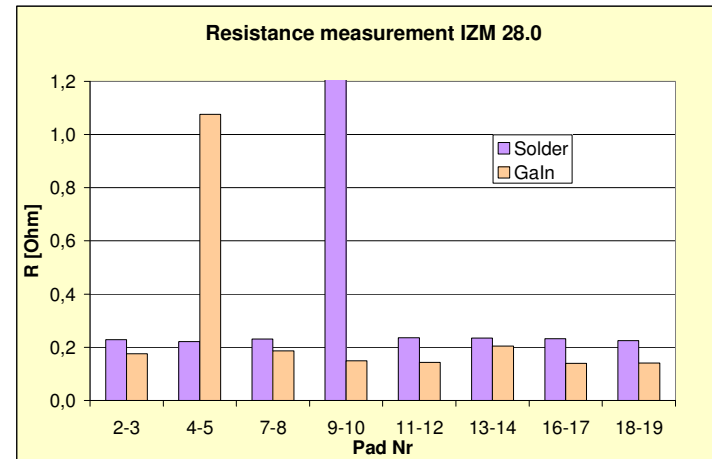
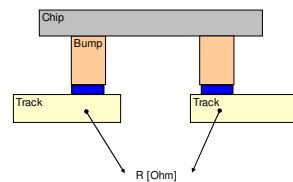
HV print system: high pressure pump and a piezo electronic actuated print head

Microfab / Microfab with High Temperature print head: contraction of a glass tube by piezo elements



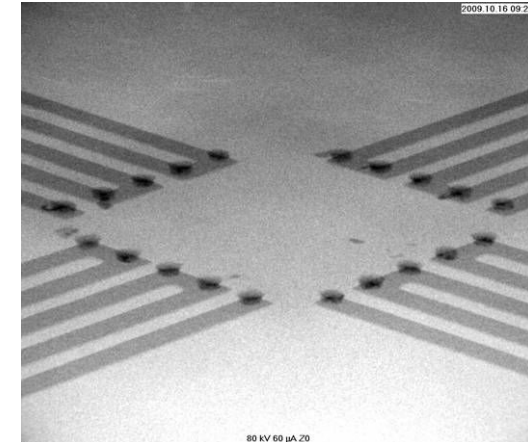
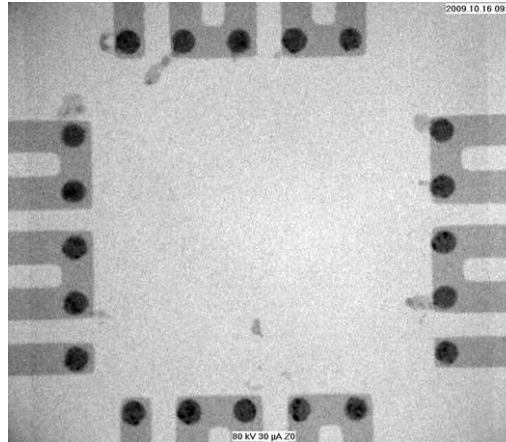
Electrical Resistance Joints

- Comparison with SnPb37 (RT)
- Thermal aging @ 85C
- 72 hr storage @ -40C

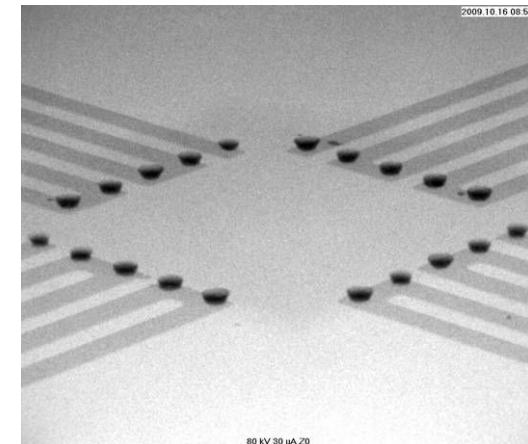
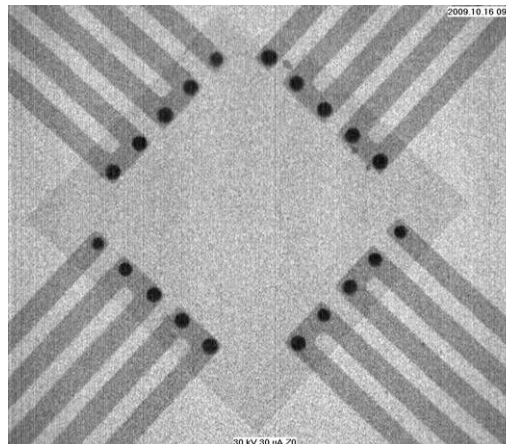


Joint Inspection: X-Ray Analysis

Liquid Metal Alloy:

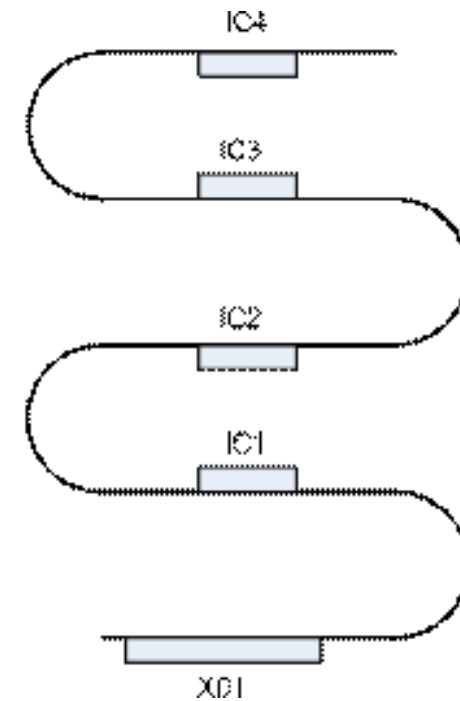
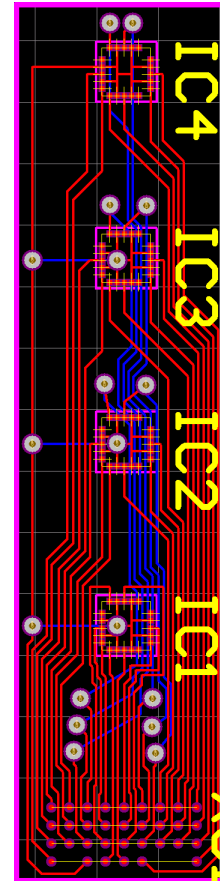
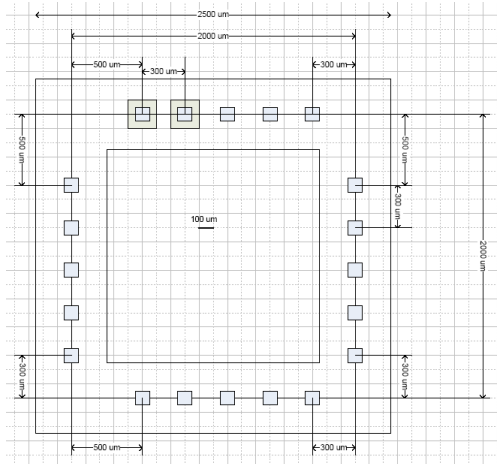


SnPb37 Solder:



Folded 3D Package

Thinned daisy chain flip chips
 Foil material: polyimide
 Line width / spacing: 100 / 100 μm
 Metallization: Immersion Ag
 2nd level pads : \varnothing 250 μm



Conclusions

- Ga-In has been used as a liquid metal alloy to connect flip chips to substrates.
- A process has been developed to demonstrate the potential of the technology and investigate joint properties.
- The initial results are promising: low temperature bonding process (<100 °C), electrical resistances joints ≈ 100 m Ω .
- Flexible and generic solution (heterogeneous system integration).
- Next step: applying liquid metal alloy in a controlled way into the cavities.

Thank you for your attention

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